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Authors: Maik Bertke, Michael Fahrbach, Gerry Hamdana,  
Jiushuai Xu, Hutomo Suryo Wasisto, Erwin Peiner



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**Contact Resonance Spectroscopy for On-The-Machine Manufactory Monitoring**

Maik Bertke, Michael Fahrbach, Gerry Hamdana, Jiushuai Xu, Hutomo Suryo Wasisto and  
Erwin Peiner

Institute of Semiconductor Technology (IHT), Technische Universität Braunschweig, Hans-  
Sommer-Straße 66, D-38106 Braunschweig, Germany

Laboratory for Emerging Nanometrology (LENA), Technische Universität Braunschweig,  
Langer Kamp 6a, D-38106 Braunschweig, Germany

**\*Corresponding Author:**

Maik Bertke

Institute of Semiconductor Technology,

Technische Universität Braunschweig, Germany

Tel: +49 531 391 3783

Fax: +49 531 391 5844

E-mail: [m.bertke@tu-braunschweig.de](mailto:m.bertke@tu-braunschweig.de)

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